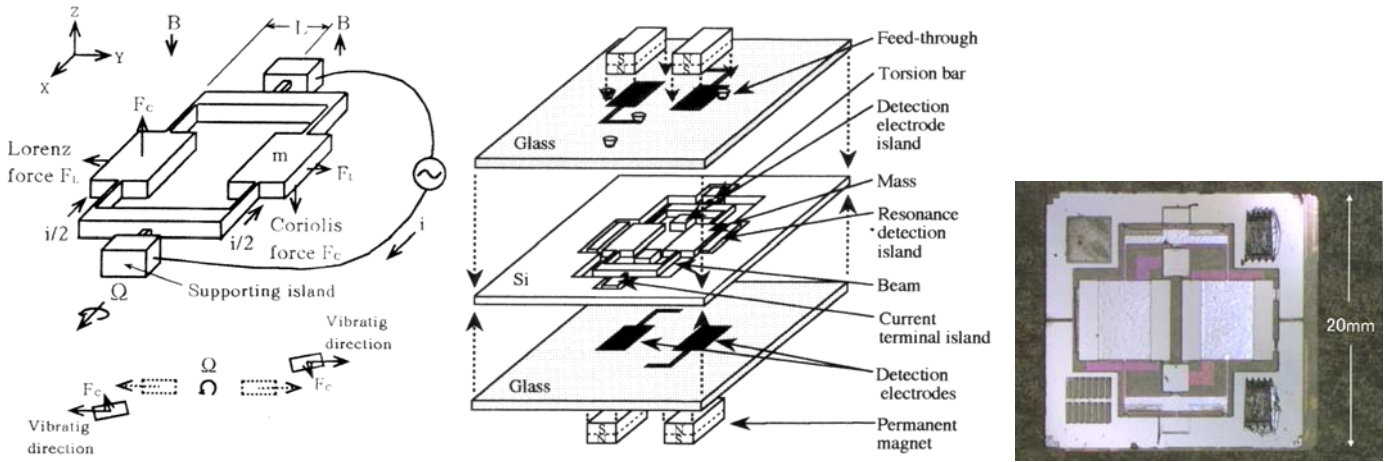
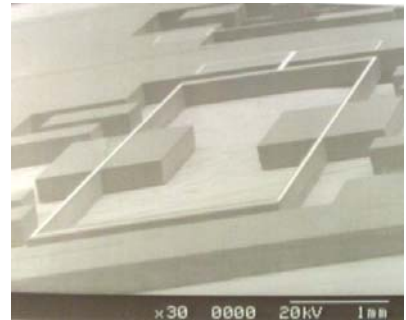
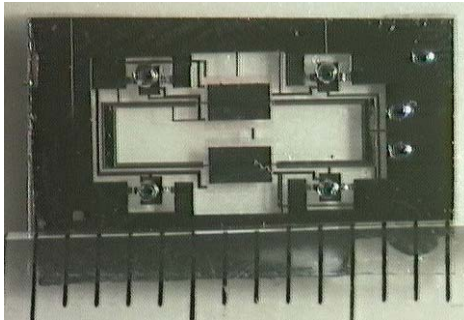
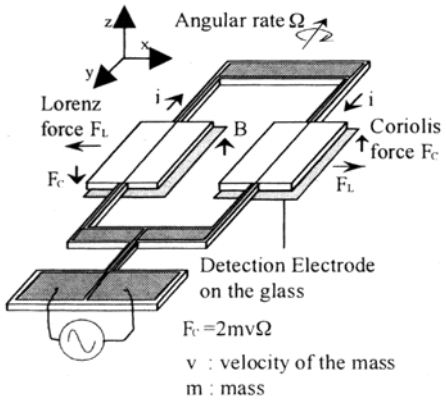


# 電磁駆動振動ジャイロ



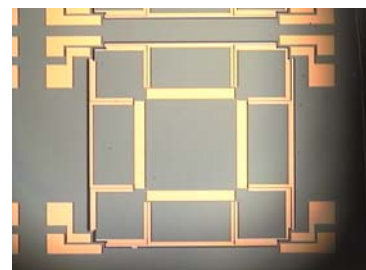
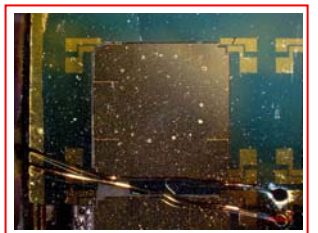
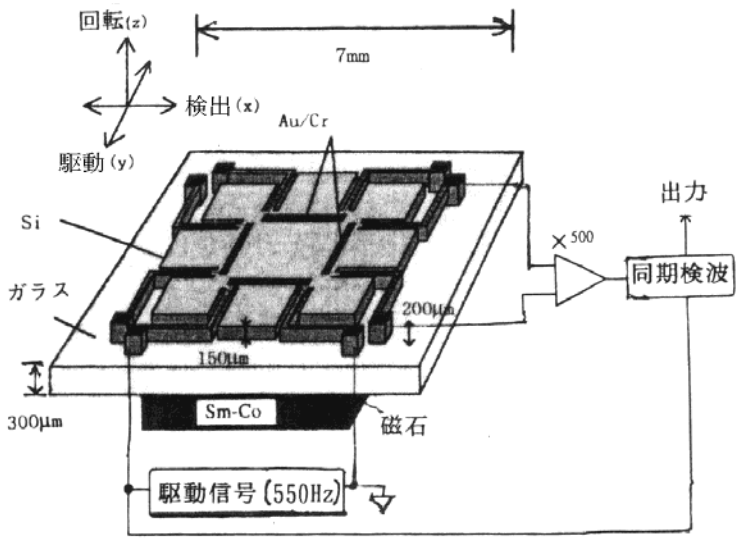
(110)Si の結晶異方性エッチングで製作した電磁駆動静電容量検出振動ジャイロ (東北大学 - トヨタ自動車)

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Deep RIE で製作した電磁駆動静電容量検出振動ジャイロ

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Z 軸用電磁駆動電磁(誘導起電力)検出振動ジャイロ

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